

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Young Hoon PARK, et al.)
) Group Art Unit: 1763
Serial No.:	10/511,883)
)
Filed:	October 19, 2004) Examiner:
) NG, James Wai Heung
For:	APPARATUS AND METHOD FOR)
	DEPOSITING THIN FILM ON WAFER)
	USING REMOTE PLASMA)

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

This Amendment is submitted in response to the Office Action dated April 5, 2007.
Please amend the Application as follows: